

S. Stevenson
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11-14-01

Docket: 0756-2306

11040 U.S. PTO
09/842315
04/26/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Taketomi ASAMI et al.)
Japanese Priority Application No. 2000-131353) Attn: Applications
Japanese Priority Date: April 28, 2000) Branch
For: MANUFACTURING METHOD FOR)
SEMICONDUCTOR DEVICE) Date: April 26, 2001

INFORMATION DISCLOSURE STATEMENT

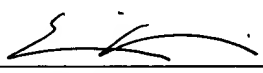
Honorable Commissioner for Patents
Washington, D.C. 20231

Sir:3

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99,
it is requested that the reference listed on the attached Form PTO-1449 be made of
record in the above-identified application.

A copy of this reference is submitted herewith in accordance with 37 C.F.R.
1.98(a).

Respectfully submitted,


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